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cas 12/21/05 6427-65559-01 466919

PATENT  
Attorney Reference Number 6427-65559-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re application of:** James F. Orsillo

**Application No.** 10/695,245

**Filed:** October 27, 2003

**Confirmation No.** 4337

**For:** APPARATUS AND METHOD FOR USE IN  
TESTING A SEMICONDUCTOR WAFER

**Examiner:** Jermele M. Hollington

**Art Unit:** 2829

**Attorney Reference No.** 6427-65559-01

**CERTIFICATE OF MAILING**

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: MAIL STOP AF, COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450 on the date shown below.

Attorney or Agent  
for Applicant(s)

Date Mailed December 22, 2005

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ALEXANDRIA, VA 22313-1450

**TRANSMITTAL LETTER**

Enclosed for filing in the application referenced above are the following:

- Amendment After Allowance.
- The Director is hereby authorized to charge any additional fees that may be required, or credit over-payment, to Deposit Account No. 02-4550. A copy of this sheet is enclosed.
- Please return the enclosed postcard to confirm that the items listed above have been received.

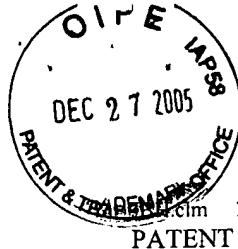
Respectfully submitted,

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By

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12/21/05 464553

**PATENT**

Attorney Reference Number 6427-65559-01

Application Number 10/695,245

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## Response Under 37

Application No. 10/695,245

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## AMENDMENT AFTER ALLOWANCE

Please amend the referenced application as follows

**Amendments to the Specification begin on page 2**

**Remarks begin on page 3.**